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Docket No.: 63004(70868)
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Junichiro Nakayama et al.

Application No.: 10/526,855

Confirmation No.: 5425

Filed: February 7, 2006

Art Unit: 2891

For: LASER PROCESSING METHOD AND
LASER PROCESSING APPARATUS

Examiner: J. Slutsker

AMENDMENT

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

Please amend the above-identified U.S. patent application as follows:

Amendments to the Drawings begin on page 2 of this paper.

Amendments to the Claims begin on page 3 of this paper.

Remarks/Arguments begin on page 7 of this paper.